



1FW
Attorney Docket No: TSMC2003-0532
[N1280-00265]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor Application of: Wei-Lian Lin et al.

Confirmation No.: 6889

Serial No.: 10/748,075

Group Art Unit: 2877

Filed: December 30, 2003

Examiner: Not Yet Assigned

For: **METHOD FOR REPAIRING OPAQUE DEFECTS ON SEMICONDUCTOR MASK
RETICLES**

I hereby certify that this correspondence is being deposited
with the United States Postal Service on the date shown below
with sufficient postage as first class mail and addressed to:
Commissioner for Patents, P.O. Box 1450, Alexandria, VA
22313-1450

Date

3-30-05
Steven E. Koffs
Steven E. Koffs, Registration No. 37,163

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CHANGE OF CORRESPONDENCE ADDRESS

Please change the correspondence address for the above-identified patent
application to:

Customer No: 08933

Steven E. Koffs, Esq.

Duane Morris LLP

One Liberty Place

Philadelphia, Pennsylvania 19103-7396

Tel: 215-979-1250

Fax: 215-979-1020

Respectfully submitted,

Dated: 3-30-05

Steven E. Koffs
Steven E. Koffs, Esquire
Registration No. 37,163
Attorney for Applicant(s)

DUANE MORRIS LLP
One Liberty Place
Philadelphia, PA 19103
215-979-1050 tel
215-979-1020 fax